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Topology optimization of optical surfaces

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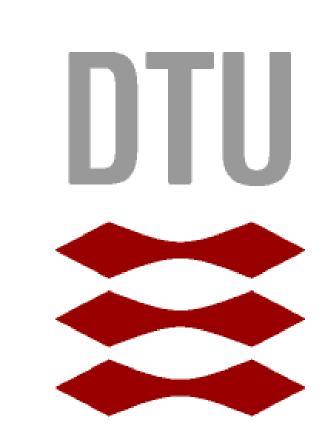




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Motivation and goals

For many applications the need for specifying and controlling the optical properties of surfaces is of high importance. Furthermore, the advances in nano-technology allow for fabrication of increasingly complex nano-structured surfaces. The problem of designing nano-structured surfaces with specific optical properties can be extremely challenging. A systematical design method is desireable to design surfaces of complex topology with tailored optical properties and to ensure design robustness considering practical dimensional tolerances.

Goals:

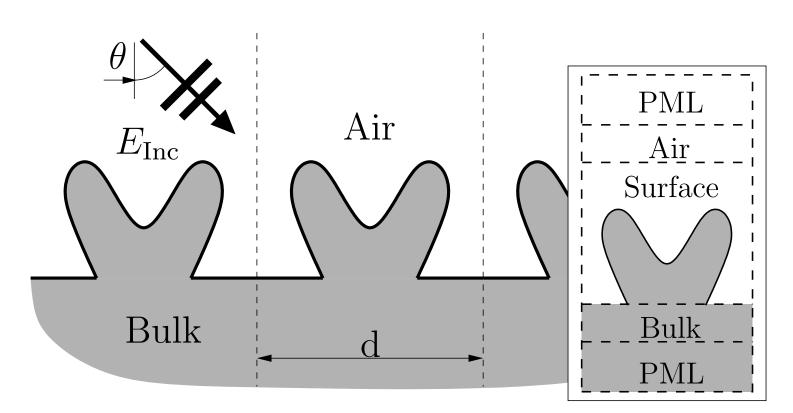
- Development of systematic method for designing optical surfaces
- Consider manufacturing tolerances and minimum length scale
- Verification of method by numerical examples

Example Applications:

- Advanced high performance gratings
- Structural color surfaces
- Optical filters

Modelling

The problem is modelled as a periodic cell



The electro-magnetic field is described by the 2D Helmholtz equation

$$\nabla \cdot (A(\mathbf{x}) \nabla u(\mathbf{x})) + \omega^2 B(\mathbf{x}) u(\mathbf{x}) = 0$$
 with polarisation dependent parameters

$$A_{\mathrm{TM}} = \frac{1}{\mu_r}, B_{\mathrm{TM}} = \frac{\epsilon_r}{c^2} \quad A_{\mathrm{TE}} = \frac{1}{\epsilon_r}, B_{\mathrm{TE}} = \frac{\mu_r}{c^2}$$

Parameterization

Robust design

Simulates

intermediate

and dilated

design reali-

sations [5]

eroded,

Material properties are interpolated by elemental material parameters

$$A_e = A_1 + \bar{\rho}_e^p (A_2 - A_1)$$

$$B_e = B_1 + \bar{\rho}_e^p (B_2 - B_1)$$

Gradient constrained

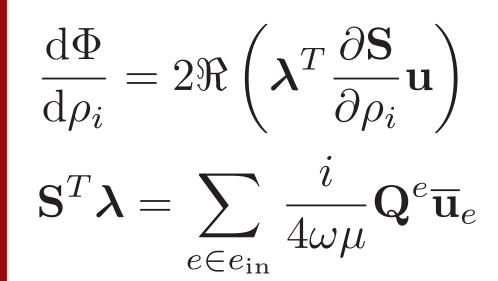
Over-etched:

Normal-etched:

Under-etched:

design field

Elemental density: $0 \leq \bar{\rho}_e(\rho) \leq 1$, for $e \in \Omega$

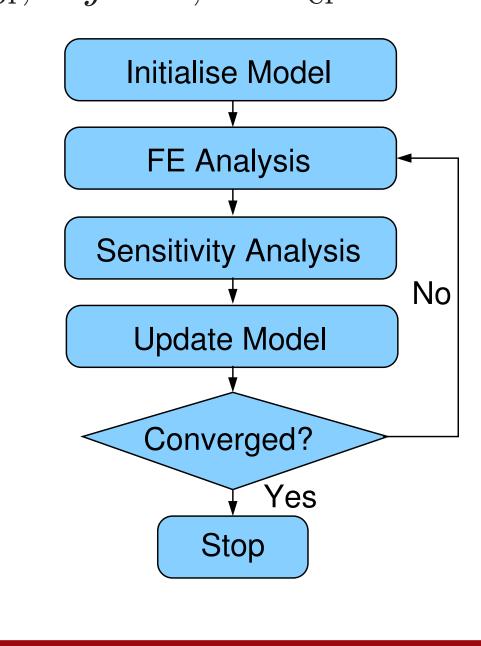


had had head had head had head



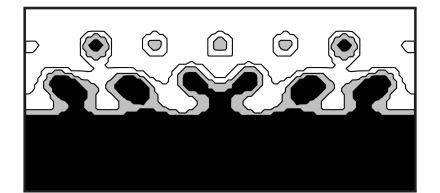
 $\min : \max : \max : \{h_i((\tilde{\rho}_j)^q)\}, \quad 0 < \rho_j \le 1,$ s.t. : $(\mathbf{K}_i^q - \omega^2 \mathbf{M}_i^q)\mathbf{u} = \mathbf{f_i}, \quad h_i = \{\text{T or R}\},$ $(\hat{\mathbf{K}}_{\mathbf{i}} - \lambda_1^q \hat{\mathbf{M}}_{\mathbf{i}}) \mathbf{x} = 0, \quad \lambda_1^q > \delta, \ q = \{e, i, d\},$ $i = 1, \dots N_{\omega, \theta, \text{pol}}, \quad j = 1, \dots N_{\text{el}}$

Design sensitivity

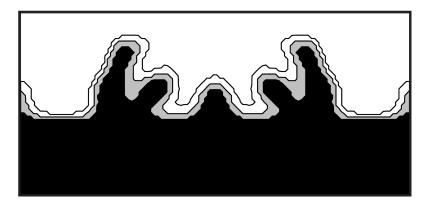


Numerical examples

Max transmittance - multiangles

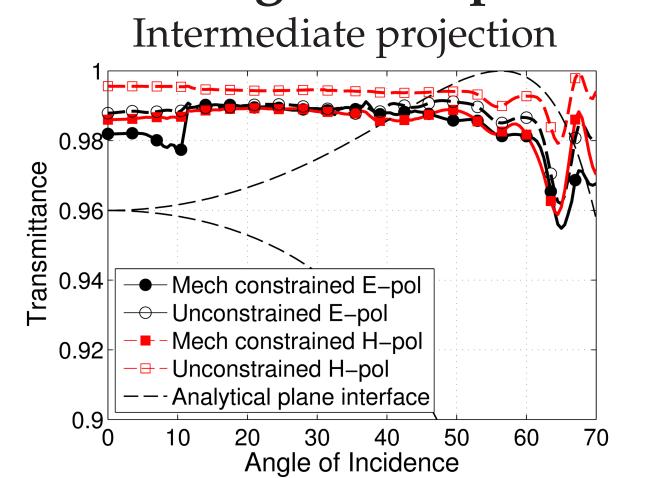


No constraints

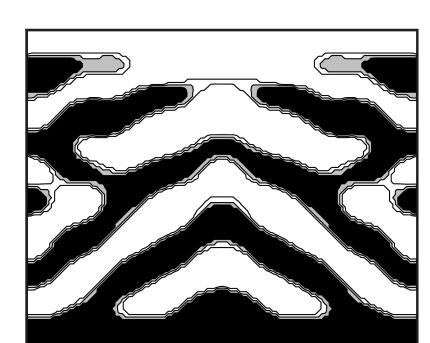


Mechanically constrained

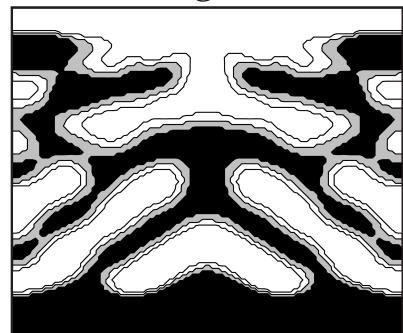
Angle sweep



Maximise reflectance - multifrequency



No constraints (initial guess)



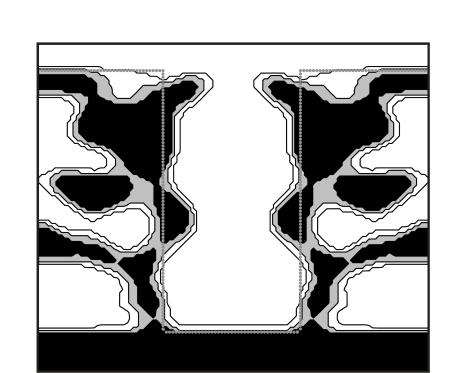
Mechanically constrained

Wavelength sweep Intermediate projection Analytical plane interface H-pol - - E-pol initial **- —** H–pol initial Wavelength

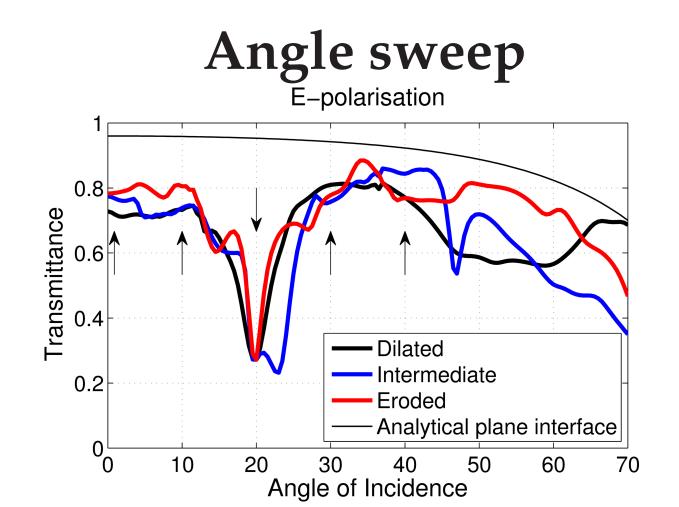


Surface design build by intermediate projection

Selective reflectance



Mechanically constrained



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Previous examples TopOpt App Cloaking Micro Extreme materials Antennas PGB splitter

